



3-10-03

IFC

PATENT
790001-2036

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tomoaki SHINO
Serial No. : 10/661,906
For : SEMICONDUCTOR DEVICE FORMED IN
SEMICONDUCTOR LAYER ON INSULATING
FILM
Filed : September 12, 2003
Examiner : Smoot, Stephen W.
Art Unit : 2813

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New York, NY 10151

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Charles Jackson
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Charles Jackson
(Signature of person mailing paper or fee)

AMENDMENT

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 14, 2004, please amend the above-identified application as follows.